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NO. 8183 P. 2/18

Docket No. 740756-945

01/08/2013

was considered with 11/17/2006 action

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent application: )  
Hisato SHINOHARA et al. )  
Application Serial No. 08/169,127 ) Art Unit: 1762  
Filed: December 20, 1993 ) Examiner: Marianne L. Padgett  
For: LASER IRRADIATION METHOD ) Date: August 25, 2006  
(AS AMENDED)

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AUG 25 2006

SUPPLEMENTAL AMENDMENT

Mail Stop AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

BEST AVAILABLE COPY

Sir:

Further to the Amendment filed June 27, 2006, please consider the following amendments and remarks in connection with this instant application.

Certificate of Mailing/Facsimile - 37 C.F.R. 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450 or facsimile transmitted to 571-273-8266 on the following date: 8/25/06

*James L. Patterson*

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